



Receipt

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Katsura OTAKI

Application No.: 09/780,414

Docket No.: 108598

Filed: February 12, 2001

For: POINT DIFFRACTION INTERFEROMETER, MANUFACTURING METHOD FOR  
REFLECTING MIRROR, AND PROJECTION EXPOSURE APPARATUS

**REQUEST FOR CORRECTION OF PALM RECORDS**

Director of the U.S. Patent and Trademark Office  
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Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records. A copy of the date-stamped postcard is also attached.

Respectfully submitted,

James A. Oliff  
Registration No. 27,075

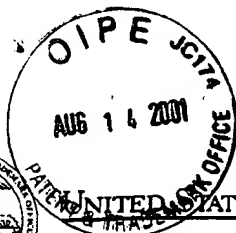
Thomas J. Pardini  
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Date: August 14, 2001

OLIFF & BERRIDGE, PLC  
P.O. Box 19928  
Alexandria, Virginia 22320  
Telephone: (703) 836-6400

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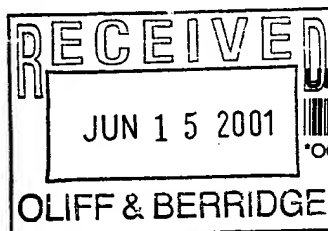


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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/780,414	05/14/2001 02/12	2877	1290	108598	6	17	7

25944  
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CONFIRMATION NO. 8508

UPDATED FILING RECEIPT



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Date Mailed: 06/13/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

**Applicant(s)**

Katsura Otaki, Tokyo, JAPAN;

**Assignment For Published Patent Application**

NIKON CORPORATION;

**Domestic Priority data as claimed by applicant****Foreign Applications**

JAPAN P2000-039092 02/17/2000

If Required, Foreign Filing License Granted 03/30/2001

Projected Publication Date: 09/20/2001

Non-Publication Request: No

Early Publication Request: No

**Title**

Point diffraction interferometer, manufacturing method for reflecting mirror, and projection exposure apparatus

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**PTO RECEIPT FOR FILING OF PAPERS**

The following papers have been filed:

Appln t ck 116221 \$1030 19pp Jap lang spec incl clms and abs 6 shts drwns (1-10)

**Name of Applicant:** Katsura OTAKI

**Serial No.:** New US Patent Application

**Atty. File No.:** 108598

**Title (New Cases):** POINT DIFFRACTION INTERFEROMETER, REFLECTION MIRROR, AND EXPOSURE APPARATUS

**Sender's Initials:** TJP/zmc

198/37



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